

# Jaichan Lee

## List of Publications by Year in descending order

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149  
papers

7,131  
citations

109137

35  
h-index

56606

83  
g-index

150  
all docs

150  
docs citations

150  
times ranked

6243  
citing authors

#	ARTICLE	IF	CITATIONS
1	Lanthanum-substituted bismuth titanate for use in non-volatile memories. Nature, 1999, 401, 682-684.	13.7	2,119
2	Fatigue and retention in ferroelectric $\text{YBaCuO}/\text{PbZrTiO}_3/\text{YBaCuO}$ heterostructures. Applied Physics Letters, 1992, 61, 1537-1539.	1.5	369
3	Oxygen Vacancy Clustering and Electron Localization in Oxygen-Deficient $\text{SrTiO}_3$ :LDA+U Study. Physical Review Letters, 2007, 98, 115503.	2.9	263
4	Voltage offsets in $(\text{Pb,La})(\text{Zr,Ti})\text{O}_3$ thin films. Applied Physics Letters, 1995, 66, 484-486.	1.5	250
5	All Graphene-Based Thin Film Transistors on Flexible Plastic Substrates. Nano Letters, 2012, 12, 3472-3476.	4.5	225
6	Differences in nature of defects between $\text{SrBi}_2\text{Ta}_2\text{O}_9$ and $\text{Bi}_4\text{Ti}_3\text{O}_{12}$ . Applied Physics Letters, 1999, 74, 1907-1909.	1.5	221
7	Effects of very thin strain layers on dielectric properties of epitaxial $\text{Ba}_{0.6}\text{Sr}_{0.4}\text{TiO}_3$ films. Applied Physics Letters, 2001, 78, 533-535.	1.5	164
8	Reliable Piezoelectricity in Bilayer $\text{WSe}_2$ for Piezoelectric Nanogenerators. Advanced Materials, 2017, 29, 1606667.	11.1	158
9	Isostructural metal-insulator transition in $\text{VO}_2$ . Science, 2018, 362, 1037-1040.	6.0	158
10	Oriented ferroelectric $\text{LaSrCoO}/\text{PbLaZrTiO}_3/\text{LaSrCoO}$ heterostructures on $[001]$ $\text{Pt}/\text{SiO}_2/\text{Si}$ substrates using a bismuth titanate template layer. Applied Physics Letters, 1994, 64, 2511-2513.	1.5	152
11	Large nonlinear dielectric properties of artificial $\text{BaTiO}_3/\text{SrTiO}_3$ superlattices. Applied Physics Letters, 2002, 80, 3581-3583.	1.5	145
12	Imprint and oxygen deficiency in $(\text{Pb,La})(\text{Zr,Ti})\text{O}_3$ thin film capacitors with $\text{LaSrCoO}$ electrodes. Applied Physics Letters, 1995, 66, 1337-1339.	1.5	132
13	Effects of crystalline quality and electrode material on fatigue in $\text{Pb}(\text{Zr,Ti})\text{O}_3$ thin film capacitors. Applied Physics Letters, 1993, 63, 27-29.	1.5	124
14	Density and spatial distribution of charge carriers in the intrinsic $n$ -type $\text{LaAlO}_3$ . Physical Review B, 2009, 79, .	1.1	123
15	Strain manipulation in $\text{BaTiO}_3/\text{SrTiO}_3$ artificial lattice toward high dielectric constant and its nonlinearity. Applied Physics Letters, 2003, 82, 2118-2120.	1.5	122
16	Characterization of amorphous $\text{SiC:H}$ films deposited from hexamethyldisilazane. Thin Solid Films, 1997, 303, 173-179.	0.8	117
17	Built-in voltages and asymmetric polarization switching in $\text{Pb}(\text{Zr,Ti})\text{O}_3$ thin film capacitors. Applied Physics Letters, 1998, 72, 3380-3382.	1.5	108
18	Oxygen-vacancy-induced ferromagnetism in $\text{CeO}_2$ first principles. Physical Review B, 2009, 79, .	1.1	105

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19	Processing and properties of Pb(Mg <sub>1/3</sub> Nb <sub>2/3</sub> )O <sub>3</sub> –PbTiO <sub>3</sub> thin films by pulsed laser deposition. Applied Physics Letters, 1995, 66, 1611-1613.	1.5	103
20	First-principles modeling of resistance switching in perovskite oxide material. Applied Physics Letters, 2006, 89, 042904.	1.5	100
21	Sharpened VO <sub>2</sub> Phase Transition via Controlled Release of Epitaxial Strain. Nano Letters, 2017, 17, 5614-5619.	4.5	93
22	Imprint of (Pb,La)(Zr,Ti)O <sub>3</sub> thin films with various crystalline qualities. Applied Physics Letters, 1996, 68, 484-486.	1.5	89
23	Growth of epitaxial Pb(Zr,Ti)O <sub>3</sub> films by pulsed laser deposition. Applied Physics Letters, 1992, 61, 1643-1645.	1.5	61
24	Imprint failures and asymmetric electrical properties induced by thermal processes in epitaxial Bi <sub>4</sub> Ti <sub>3</sub> O <sub>12</sub> thin films. Journal of Applied Physics, 1998, 84, 4428-4435.	1.1	59
25	Scaling of ferroelectric properties in La <sub>0.6</sub> Sr <sub>0.4</sub> CoO <sub>3</sub> /Pb <sub>0.6</sub> La <sub>0.4</sub> Zr <sub>0.2</sub> Ti <sub>0.2</sub> O <sub>3</sub> /La <sub>0.6</sub> Sr <sub>0.4</sub> CoO <sub>3</sub> capacitors. Applied Physics Letters, 1994, 64, 1588-1590.	1.5	54
26	Effects of interface charges on imprint of epitaxial Bi <sub>4</sub> Ti <sub>3</sub> O <sub>12</sub> thin films. Applied Physics Letters, 1997, 70, 1101-1103.	1.5	52
27	Quantum confinement-induced tunable exciton states in graphene oxide. Scientific Reports, 2013, 3, 2250.	1.6	52
28	Dielectric properties of strained (Ba, <sub>0.5</sub> Sr)TiO <sub>3</sub> thin films epitaxially grown on Si with thin yttria-stabilized zirconia buffer layer. Applied Physics Letters, 2001, 78, 2542-2544.	1.5	51
29	Tunable ferroelectricity in artificial tri-layer superlattices comprised of non-ferroic components. Nature Communications, 2012, 3, 1064.	5.8	51
30	Oxygen Vacancy Linear Clustering in a Perovskite Oxide. Journal of Physical Chemistry Letters, 2017, 8, 3500-3505.	2.1	48
31	Effect of ultraviolet light on fatigue of lead zirconate titanate thin film capacitors. Applied Physics Letters, 1994, 65, 254-256.	1.5	44
32	A multisized piezoelectric microcantilever biosensor array for the quantitative analysis of mass and surface stress. Applied Physics Letters, 2008, 93, .	1.5	43
33	Ferroelectric/superconductor PbZr <sub>0.52</sub> Ti <sub>0.48</sub> O <sub>3</sub> /Y <sub>1</sub> Ba <sub>2</sub> Cu <sub>3</sub> O <sub>7-x</sub> /LaAlO <sub>3</sub> heterostructure prepared by Nd:YAG pulsed laser deposition. Applied Physics Letters, 1994, 64, 3646-3648.	1.5	42
34	Selective Semihydrogenation of Alkynes on Shape-Controlled Palladium Nanocrystals. Chemistry - an Asian Journal, 2013, 8, 919-925.	1.7	39
35	Epitaxial growth and properties of YBa <sub>2</sub> Cu <sub>3</sub> O <sub>x</sub> –Pb(Zr <sub>0.6</sub> Ti <sub>0.4</sub> )O <sub>3</sub> –YBa <sub>2</sub> Cu <sub>3</sub> O <sub>x</sub> trilayer structure by laser ablation. Applied Physics Letters, 1992, 61, 528-530.	1.5	36
36	Effects of process parameters on the growth of thick SiO <sub>2</sub> using plasma enhanced chemical vapor deposition with hexamethyldisilazane. Surface and Coatings Technology, 2000, 131, 136-140.	2.2	35

#	ARTICLE	IF	CITATIONS
37	Polarization of strained BaTiO <sub>3</sub> /SrTiO <sub>3</sub> artificial superlattice: First-principles study. Applied Physics Letters, 2005, 87, 052903.	1.5	35
38	Metal-insulator transition in low dimensional La <sub>0.75</sub> Sr <sub>0.25</sub> VO <sub>3</sub> thin films. Applied Physics Letters, 2011, 99, 112111.	1.5	35
39	Enhanced catalytic behavior of Ni alloys in steam methane reforming. Journal of Power Sources, 2017, 359, 450-457.	4.0	35
40	Hydrogen adsorption and carrier generation in LaAlO <sub>3</sub> /SrTiO <sub>3</sub> heterointerfaces: a first-principles study. Journal of Physics Condensed Matter, 2010, 22, 315501.	0.7	34
41	Structural transition and dielectric response of an epitaxially strained BaTiO <sub>3</sub> /SrTiO <sub>3</sub> superlattice: A first-principles study. Physical Review B, 2005, 72, .	1.1	30
42	Direct growth of orthorhombic Hf <sub>0.5</sub> Zr <sub>0.5</sub> O <sub>2</sub> thin films for hysteresis-free MoS <sub>2</sub> negative capacitance field-effect transistors. Npj 2D Materials and Applications, 2021, 5, .	3.9	29
43	Electrical properties of Bi <sub>3.25</sub> La <sub>0.75</sub> Ti <sub>3</sub> O <sub>12</sub> thin films on Si for a metal/ferroelectric/insulator/semiconductor structure. Applied Physics Letters, 2001, 79, 1516-1518.	1.5	28
44	Effects of interfacial oxygen-deficient layer on resistance switching in Cr-doped SrTiO <sub>3</sub> thin films. Applied Physics Letters, 2008, 93, .	1.5	28
45	Reversible pyroelectric and photogalvanic current in epitaxial Pb(Zr <sub>0.52</sub> Ti <sub>0.48</sub> )O <sub>3</sub> thin films. Applied Physics Letters, 1994, 64, 294-296.	1.5	27
46	Bi modification for low-temperature processing of YMnO <sub>3</sub> thin films. Applied Physics Letters, 2004, 84, 5043-5045.	1.5	27
47	Sol-gel Derived Epitaxial MgTiO <sub>3</sub> Thin Films. Japanese Journal of Applied Physics, 1999, 38, 3651-3654.	0.8	26
48	Structural and dielectric properties of artificial PbZrO <sub>3</sub> /PbTiO <sub>3</sub> superlattices grown by pulsed laser deposition. Thin Solid Films, 2005, 475, 283-286.	0.8	25
49	Investigation of thermodynamic properties of cerium dioxide by statistical moment method. Journal of Physics and Chemistry of Solids, 2006, 67, 682-689.	1.9	25
50	Nonadiabatic small polaron tunneling conduction in reduced Cr-doped SrTiO <sub>3</sub> thin films. Applied Physics Letters, 2009, 94, 232102.	1.5	25
51	Sol-gel derived (La, Sr)CoO <sub>3</sub> thin films on silica glass. Thin Solid Films, 1999, 341, 13-17.	0.8	23
52	Tunable two-dimensional or three-dimensional electron gases by submonolayer La doping of SrTiO <sub>3</sub> . $\langle \text{mml:mrow} \langle \text{mml:msub} \langle \text{mml:mrow} / \rangle \langle \text{mml:mrow} \rangle \langle \text{mml:mn} \rangle 3 \langle \text{mml:mn} \rangle \langle \text{mml:mrow} \rangle \langle \text{mml:msub} \rangle \langle \text{mml:mrow} \rangle \langle \text{mml:math} \rangle .$ Physical Review B, 2011, 83, .	1.1	23
53	MgTiO <sub>3</sub> thin films prepared by metalorganic solution deposition and their properties. Thin Solid Films, 2001, 385, 43-47.	0.8	21
54	Characterization of (Ba <sub>0.5</sub> ,Sr <sub>0.5</sub> )TiO <sub>3</sub> thin films by the laser ablation technique and their electrical properties with different electrodes. Integrated Ferroelectrics, 1995, 7, 329-339.	0.3	20

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55	Fabrication and Sensing Behavior of Piezoelectric Microcantilever for Nanobalance. Japanese Journal of Applied Physics, 2003, 42, 6139-6142.	0.8	20
56	Hopping and trap controlled conduction in Cr-doped SrTiO <sub>3</sub> thin films. Solid-State Electronics, 2012, 75, 43-47.	0.8	20
57	Gas Sensor Application of Piezoelectric Cantilever Nanobalance; Electrical Signal Read-Out. Ferroelectrics, 2005, 328, 59-65.	0.3	19
58	First-principles calculation of capacitance including interfacial effects. Journal of Applied Physics, 2008, 103, 024106.	1.1	19
59	Asymmetric switching and imprint in (La,Sr)CoO <sub>3</sub> /Pb(Zr,Ti)O <sub>3</sub> /(La,Sr)CoO <sub>3</sub> heterostructures. Integrated Ferroelectrics, 1997, 18, 39-48.	0.3	18
60	Dielectric properties of BaTiO <sub>3</sub> •SrTiO <sub>3</sub> ferroelectric thin film artificial lattice. Journal of Applied Physics, 2006, 100, 051613.	1.1	18
61	Trap-Controlled Space-Charge-Limited Current Conduction in the Cr-Doped SrTiO <sub>3</sub> Thin Films Deposited by Using Pulsed Laser Deposition. Journal of the Korean Physical Society, 2007, 51, 664.	0.3	17
62	Structural evolution and characterization of heteroepitaxial GaSb thin films on Si(111) substrates. Journal of Applied Physics, 2007, 101, 073707.	1.1	15
63	Strain dependent polarization and dielectric properties of epitaxial BaTiO <sub>3</sub> from first-principles. Journal of Applied Physics, 2012, 112, 014109.	1.1	14
64	Disordered ferroelectricity in the PbTiO <sub>3</sub> /SrTiO <sub>3</sub> superlattice thin film. APL Materials, 2017, 5, 066104.	2.2	14
65	Landau-Khalatnikov simulations for the effects of external stresses on the ferroelectric properties of Pb(Zr,Ti)O <sub>3</sub> thin films. Thin Solid Films, 2003, 424, 84-87.	0.8	13
66	Relaxor characteristics at the interfaces of $\text{NdMnO}_3$ Physical Review B, 2010, 82, .	1.1	13
67	Ferroelectric properties and reliability of La-Sr-Co-O/Pb-La-Zr-Ti-O/La-Sr-Co-O heterostructures on si for non-volatile memory applications. Integrated Ferroelectrics, 1995, 9, 317-333.	0.3	12
68	Ferroelectric field effect in (La,Sr)CoO <sub>3</sub> /Pb(Zr,Ti)O <sub>3</sub> /(La,Sr)CoO <sub>3</sub> heterostructures. Integrated Ferroelectrics, 1997, 18, 405-414.	0.3	12
69	Strain effect on dielectric property of SrTiO <sub>3</sub> lattice: first-principles study. Thin Solid Films, 2005, 475, 97-101.	0.8	12
70	Fatigue and photoresponse of lead zirconate titanate thin film capacitors. Integrated Ferroelectrics, 1995, 6, 289-300.	0.3	10
71	Optical phonon softening in strained SrTiO <sub>3</sub> thin film: First-principles study. Applied Physics Letters, 2004, 85, 5649-5651.	1.5	10
72	A study of lead zirconate titanate etching characteristics using magnetized inductively coupled plasmas. Surface and Coatings Technology, 2000, 131, 257-260.	2.2	9

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73	Growth of MgTiO <sub>3</sub> thin films by pulsed laser deposition and their electrical properties. Integrated Ferroelectrics, 2000, 31, 97-104.	0.3	9
74	Fermion condensation quantum phase transition versus conventional quantum phase transitions. Physics Letters, Section A: General, Atomic and Solid State Physics, 2004, 329, 108-115.	0.9	9
75	AC Electrical Conduction of Cr-Doped SrTiO <sub>3</sub> Thin Films. Journal of the Korean Physical Society, 2009, 54, 873-876.	0.3	9
76	Etching characteristics of lead magnesium niobate/lead titanate (PMN/PT) relaxor ferroelectrics. Surface and Coatings Technology, 2000, 131, 252-256.	2.2	8
77	Residual stress analysis of SiO <sub>2</sub> films deposited by plasma-enhanced chemical vapor deposition. Surface and Coatings Technology, 2000, 131, 153-157.	2.2	8
78	ELECTRONIC STRUCTURE OF OXYGEN DEFICIENT BaTiO <sub>3</sub> . Integrated Ferroelectrics, 2006, 84, 23-30.	0.3	8
79	Orbital-selective charge transfer at oxygen-deficient LaAlO <sub>3</sub> /SrTiO <sub>3</sub> interfaces. Physical Review B, 2013, 87, 081101.	1.1	8
80	Etch characteristics of optical waveguides using inductively coupled plasmas with multidipole magnets. Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films, 1999, 17, 1483-1487.	0.9	7
81	Thickness Dependent Dielectric Property of BaTiO <sub>3</sub> /SrTiO <sub>3</sub> Artificial Lattice. Japanese Journal of Applied Physics, 2003, 42, 5901-5903.	0.8	7
82	Design of Piezoelectric Actuator for Braille Module by Finite Element Method. Journal of Nanoscience and Nanotechnology, 2019, 19, 1308-1314.	0.9	7
83	Expediently Crystallized Pure Orthorhombic-Hf <sub>0.5</sub> Zr <sub>0.5</sub> O <sub>2</sub> for Negative Capacitance Field Effect Transistors. ACS Applied Materials & Interfaces, 2021, 13, 60250-60260.	4.0	7
84	Ferroelectric La-Sr-Co-O/Pb-La-Zr-Ti-O/La-Sr-Co-O heterostructures on silicon. Integrated Ferroelectrics, 1994, 5, 145-154.	0.3	6
85	Fabrication and properties of microcantilever using piezoelectric PZT thin films. Ferroelectrics, 2001, 263, 241-246.	0.3	6
86	Ferroelectricity in Ultrathin PbZrO <sub>3</sub> /PbTiO <sub>3</sub> Artificial Superlattices by Scanning Probe Microscopy. Ferroelectrics, 2006, 336, 271-277.	0.3	6
87	IMPEDANCE SPECTROSCOPY STUDY ON TRAP-CONTROLLED SPACE-CHARGE-LIMITED CONDUCTION OF Cr-DOPED SrTiO <sub>3</sub> THIN FILMS. Integrated Ferroelectrics, 2008, 96, 146-152.	0.3	6
88	Nano-domain engineering in ultrashort-period ferroelectric superlattices. Applied Physics Letters, 2012, 100, 222906.	1.5	6
89	Unipolar resistance switching characteristics in a thick ZnO/Cu/ZnO multilayer structure. Journal of the Korean Physical Society, 2012, 60, 1087-1091.	0.3	6
90	AC Electrical Conduction of Cr-Doped SrTiO <sub>3</sub> Thin Films with an Oxygen-Deficient Interface Layer. Journal of Electronic Materials, 2017, 46, 3796-3800.	1.0	6

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91	Electronâ€™Lattice Coupling in Correlated Materials of Low Electron Occupancy. Nano Letters, 2017, 17, 5458-5463.	4.5	6
92	Fabrication and testing of micron-size (Pb,La)(Zr,Ti)O <sub>3</sub> thin film capacitors. Integrated Ferroelectrics, 1995, 8, 35-44.	0.3	5
93	Pb(Zr,Ti)O <sub>3</sub> films fabrication by sol-gel method for piezoelectric actuated device. Ferroelectrics, 1999, 232, 247-252.	0.3	5
94	Dielectric Properties of PbZrO <sub>3</sub> /PbTiO <sub>3</sub> Artificial Superlattices Grown by Pulsed Laser Deposition. Ferroelectrics, 2005, 328, 41-46.	0.3	5
95	First principles study of tantalum thermodynamics by the statistical moment method. Computational Materials Science, 2006, 37, 565-571.	1.4	5
96	Study of Self-Diffusion in Silicon at High Pressure. Journal of the Physical Society of Japan, 2006, 75, 024601.	0.7	5
97	An influence of bottom electrode material on electrical conduction and resistance switching of TiO <sub>x</sub> thin films. EPJ Applied Physics, 2013, 64, 30102.	0.3	5
98	Study of the Resistive Switching Effect in Chromium Oxide Thin Films by Use of Conductive Atomic Force Microscopy. Journal of Electronic Materials, 2015, 44, 3395-3400.	1.0	5
99	The effect of stress on the electrical properties of PZT thin films. Ferroelectrics, 2001, 259, 251-257.	0.3	4
100	Fabrication and Electromechanical Properties of Piezoelectric Micro-Transducers for Smart Device. Integrated Ferroelectrics, 2003, 54, 679-687.	0.3	4
101	LATTICE INSTABILITIES OF BaTiO <sub>3</sub> /SrTiO <sub>3</sub> ARTIFICIAL SUPERLATTICE. Integrated Ferroelectrics, 2005, 73, 3-10.	0.3	4
102	Growth of SrTiO <sub>3</sub> /(Sr <sub>1-x</sub> La <sub>x</sub> )TiO <sub>3</sub> Superlattices and Lattice Strain Development. Ferroelectrics, 2006, 336, 255-261.	0.3	4
103	Dielectric Properties of Ultrathin SrTiO <sub>3</sub> and Metal-SrTiO <sub>3</sub> Interfaces. Journal of the Korean Physical Society, 2008, 52, 70-74.	0.3	4
104	Effect of (La, Sr)CoO <sub>3</sub> seed layer on the reliability of Pb(Zr, Ti)O <sub>3</sub> capacitors. Integrated Ferroelectrics, 1999, 25, 341-350.	0.3	3
105	The strain-induced ferroelectric properties of c-axis oriented (Ba,Sr)TiO <sub>3</sub> thin films. Surface and Coatings Technology, 2000, 131, 552-557.	2.2	3
106	Hysteresis caused by defects in buffer layer of metal-ferroelectric-insulator-semiconductor (MFIS) devices. Integrated Ferroelectrics, 2001, 40, 245-254.	0.3	3
107	Growth of Oxide BTO/STO Artificial Superlattice by Pulsed Laser Deposition. Ferroelectrics, 2002, 272, 369-374.	0.3	3
108	Ferroelectric Properties of PbZrO <sub>3</sub> /PbTiO <sub>3</sub> Artificial Superlattices by Scanning Probe Microscopy. Integrated Ferroelectrics, 2004, 68, 13-18.	0.3	3

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109	Effect of Oxygen Cooling Environment on the Structural Characteristics and Dielectric Properties of BaTiO <sub>3</sub> and SrTiO <sub>3</sub> Thin Films. <i>Ferroelectrics</i> , 2005, 327, 103-109.	0.3	3
110	PIEZOELECTRICALLY DRIVEN MICROTRANSDUCER MASS SENSORS. <i>Integrated Ferroelectrics</i> , 2006, 80, 355-362.	0.3	3
111	Piezoelectrically Driven Self-Excited Microbridge VOCs Sensor. <i>Ferroelectrics</i> , 2006, 338, 41-47.	0.3	3
112	Electrical properties of SrTiO <sub>3</sub> /(Sr <sup>1/2</sup> ,La)TiO <sub>3</sub> superlattices grown by laser molecular beam epitaxy. <i>Surface and Coatings Technology</i> , 2007, 201, 5374-5377.	2.2	3
113	ELECTROMECHANICAL PERFORMANCE OF PIEZOELECTRIC ACTUATORS IN INKJET PRINT HEAD. <i>Integrated Ferroelectrics</i> , 2008, 98, 251-258.	0.3	3
114	Asymmetric properties of Pb(Zr,Ti)O <sub>3</sub> thin film capacitors with conducting oxides. <i>European Physical Journal Special Topics</i> , 1998, 08, Pr9-109-Pr9-112.	0.2	3
115	Reversible Photo-Induced Currents in Epitaxial Pb(Zr <sub>0.52</sub> Ti <sub>0.48</sub> )O <sub>3</sub> Thin Films. <i>Materials Research Society Symposia Proceedings</i> , 1993, 310, 107.	0.1	2
116	Pulsed laser deposition of Bi <sub>4</sub> Ti <sub>3</sub> O <sub>12</sub> thin films and their anomalous imprint characteristics. <i>Integrated Ferroelectrics</i> , 1997, 14, 181-191.	0.3	2
117	The electrical properties and retention characteristics of strained PZT thin film capacitors. <i>Integrated Ferroelectrics</i> , 2001, 37, 285-294.	0.3	2
118	Surface segregation of hexagonal boron nitride and its surface properties. <i>Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films</i> , 2001, 19, 1013-1017.	0.9	2
119	Asymmetric capacitance-voltage characteristics of (Bi <sub>3.25</sub> , La <sub>0.75</sub> )Ti <sub>3</sub> O <sub>12</sub> thin films grown on Si. <i>Integrated Ferroelectrics</i> , 2001, 40, 225-234.	0.3	2
120	Structural and Dielectric Properties of BaTiO <sub>3</sub> /SrTiO <sub>3</sub> Artificial Superlattice on MgO and SrTiO <sub>3</sub> Single Crystal Substrates. <i>Integrated Ferroelectrics</i> , 2002, 50, 219-228.	0.3	2
121	PIEZOELECTRICALLY DRIVEN MICROTRANSDUCER MASS SENSORS. <i>Integrated Ferroelectrics</i> , 2005, 76, 93-100.	0.3	2
122	Fabrication and Electromechanical Properties of Pb(Zr <sub>0.52</sub> ,Ti <sub>0.48</sub> )O <sub>3</sub> Micro-Diaphragm. <i>Integrated Ferroelectrics</i> , 2005, 69, 383-390.	0.3	2
123	Gas Sensors Based on Piezoelectric Micro-Diaphragm Transducer. <i>Integrated Ferroelectrics</i> , 2005, 69, 333-339.	0.3	2
124	Variations of microstructures and electrical properties of Bi <sub>4</sub> Ti <sub>3</sub> O <sub>12</sub> /SrTiO <sub>3</sub> /(La <sub>0.5</sub> , Sr <sub>0.5</sub> )CoO <sub>3</sub> /MgO epitaxial thin films by annealing. <i>Thin Solid Films</i> , 2010, 518, 5630-5636.	0.8	2
125	STUDY OF IONIC CONDUCTIVITY IN CUBIC CERIA BY THE STATISTICAL MOMENT METHOD. <i>Modern Physics Letters B</i> , 2011, 25, 1101-1110.	1.0	2
126	Numerical and Experimental Study of Actuator Performance on Piezoelectric Microelectromechanical Inkjet Print Head. <i>Journal of Nanoscience and Nanotechnology</i> , 2013, 13, 8079-8085.	0.9	2



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127	Geometric tuning of charge and spin correlations in manganite superlattices. Applied Physics Letters, 2015, 106, 023120.	1.5	2
128	Dielectric Behavior of BaTiO <sub>3</sub> /SrTiO <sub>3</sub> Oxide Artificial Lattice by Strain Manipulation. Integrated Ferroelectrics, 2003, 58, 1327-1335.	0.3	2
129	Electrical characterizations of MgTiO <sub>3</sub> thin films grown on Si. Integrated Ferroelectrics, 2000, 31, 359-366.	0.3	1
130	The growth and electrical properties of ferroelectric (Bi <sub>3.25</sub> La <sub>0.75</sub> )Ti <sub>3</sub> O <sub>12</sub> thin films for metal-ferroelectric-insulator-semiconductor. Ferroelectrics, 2001, 261, 131-137.	0.3	1
131	Dielectric Properties of BaTiO <sub>3</sub> /SrTiO <sub>3</sub> Oxide Superlattice. AIP Conference Proceedings, 2002, , .	0.3	1
132	Low-Temperature Process of Ferroelectric (Y <sub>0.95</sub> Bi <sub>0.05</sub> )MnO <sub>3</sub> Thin Films and Their Structural and Electrical Properties. Integrated Ferroelectrics, 2003, 52, 163-170.	0.3	1
133	EPITAXIALLY GROWN PbZr <sub>0.3</sub> Ti <sub>0.7</sub> O <sub>3</sub> THIN FILMS ON LaMnO <sub>3</sub> APPLICABLE TO NANO-STORAGE MEDIA. Integrated Ferroelectrics, 2005, 75, 139-146.	0.3	1
134	RESISTIVE SWITCHING AND THRESHOLD CURRENT OF Cr-DOPED SrTiO <sub>3</sub> THIN FILMS DEPOSITED BY PULSED LASER DEPOSITION. Integrated Ferroelectrics, 2007, 90, 107-112.	0.3	1
135	Metallic characteristics in superlattices composed of insulators, NdMnO <sub>3</sub> /SrMnO <sub>3</sub> /LaMnO <sub>3</sub> . Applied Physics Letters, 2011, 98, 171910.	1.5	1
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